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## \*BIBDATASHEET\*

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APPLICANTS

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\*\* CONTINUING DATA *MK (NONE)* \*\*\*\*\*

\*\* FOREIGN APPLICATIONS *MK (NONE)* \*\*\*\*\*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\* SMALL ENTITY \*\*  
 \*\* 02/21/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Signature</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 1	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 3
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TITLE  
 Semiconductor wafer cleaning apparatus and cleaning method using the same

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees ( Filing )